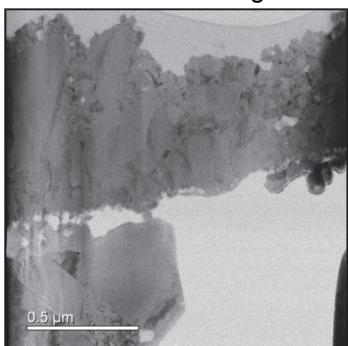


Evaluation of Cu oxides with (S) TEM

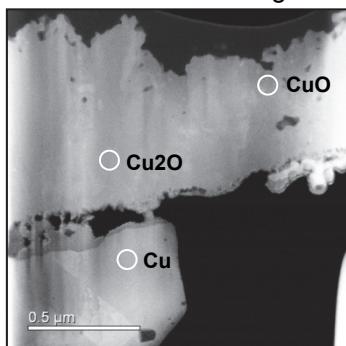
Examples of evaluation for oxidation states at nm area with (S)TEM are shown. Chemical states mapping are acquired with composition analysis by EDS(including quantification) and EELS combining with multiple linear least-squares(MLLS) fitting analysis. Crystal structure identification by electron diffraction are also available.

Observation of Cu-oxides by STEM

BF-STEM Image

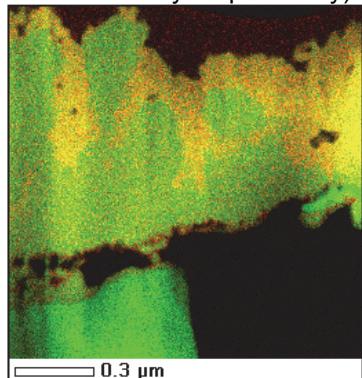


HAADF-STEM Image

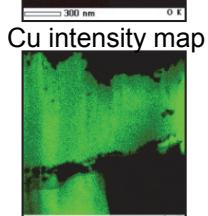
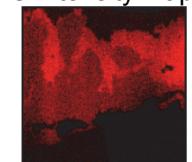


Quantitative composition mapping by STEM-EDS

EDS Intensity Map(overlay)

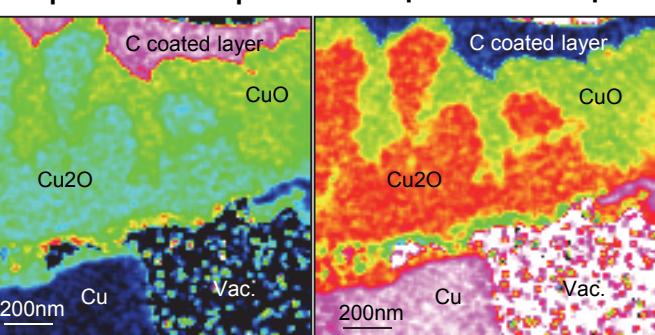


O intensity map

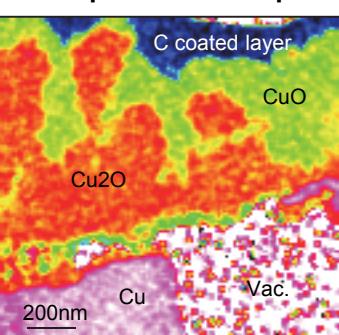


Quantification

O quantitative map



Cu quantitative map

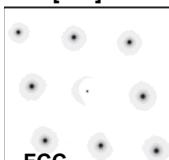


There are no information for oxidation states in STEM images.

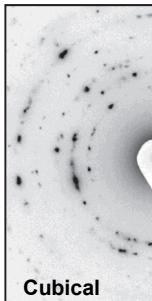
Identification for Cu-oxides by Electron diffraction

SAED pattern from each point in above HAADF image.

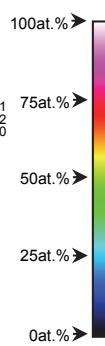
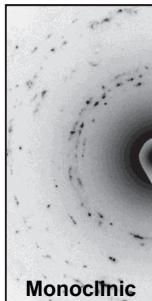
Cu [110] Incidence



Cu2O



CuO

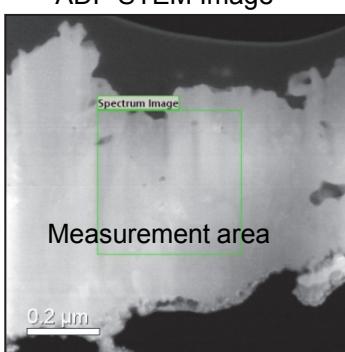


ED provide information about crystal structures

Quantitative EDS mapping clarify the distribution of Cu, CuO and Cu2O respectively. This method can apply for thicker(^100nm) foils of samples.

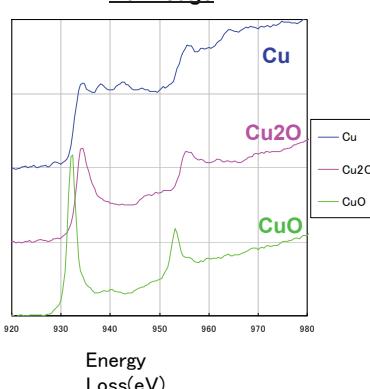
Chemical states mapping with EELS

ADF-STEM Image

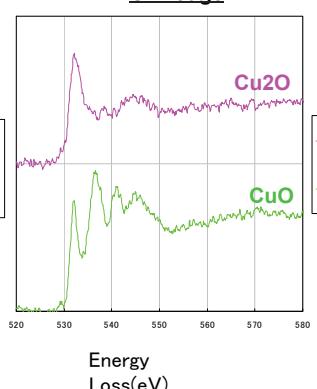


ELNES(Energy Loss Near Edge Structure)

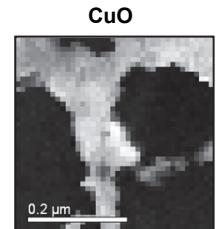
Cu-L edge



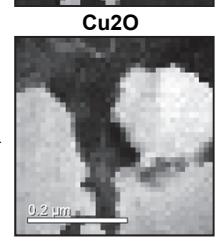
O-K edge



MLLS Fitting at Cu-L edge



MLLS:Multiple linear least-squares



Chemical States map can be acquired with peak separation utilizing difference of form of Cu-L edge between each cu-oxides.



Toray Research Center, Inc.

P01144形態科学第2研究室20140520

STC:開(20141121)